

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,992,549 B2  
APPLICATION NO. : 10/771820  
DATED : January 31, 2006  
INVENTOR(S) : John A. Higgins

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In column 4, line 66, change "MEMC" to -- MEMS --

In column 10, line 63, insert -- on the -- after "71", so that the text should read -- layer of the structure 71 on the walls 72-75, and the details of the --

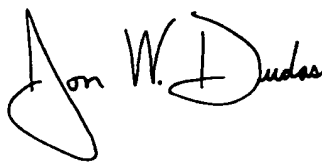
In column 12, line 22, change "114" to -- 134 --, insert a comma after "below" so that the text should read -- 144 pulled to the strips 134 below, the high impedance --

In column 14, line 53, change "impedance" to read -- impedance --

Replace drawing sheet 8 of 9 with the attached replacement drawing

Signed and Sealed this

Third Day of October, 2006

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a distinct "D" at the end.

JON W. DUDAS  
*Director of the United States Patent and Trademark Office*

